



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of: **Naoto Horiguchi**

Group Art Unit: **2822**

Application Number: **10/806,247**

Examiner: **Thanh Y. Tran**

Filed: **March 23, 2004**

Confirmation Number: **1770**

For: **SEMICONDUCTOR DEVICE AND MANUFACTURING  
METHOD THEREOF**

Attorney Docket Number: **042261**  
Customer Number: **38834**

**REQUEST FOR EXAMINER'S INTERVIEW**

**Mail Stop: RCE**

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

December 18, 2006

Sir:

Applicant hereby requests a personal interview with Examiner Thanh Y. Tran for the above-identified application. The Examiner is encouraged to telephone the Applicant's representative, Mr. Hubbs, to schedule the interview at a time that is convenient to the Examiner.

Respectfully submitted,

**WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP**

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